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Substitute for form 1449B/PTO		Complete if Known				
		Application Number	09/804,817			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Filing Date	March 13, 2001			
		First Named Inventor	Richard D. Harris			
		Group Art Unit	2811			
		Examiner Name				
Sheet	2	of	4	Attorney Docket Number	110003.97354	FEB 13 2002

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	1	Toumazou, C. et al., n-step Charge Injection Cancellation Scheme for Very Accurate Switched Current Circuits, Electronic Letters, V.30 (9) 680-681: 1994.	
	2	Emmerich, H., et al., A Novel Micromachined Magnetic-Field Sensor, MEMS 99 IEEE Conference, January 17-21, 1999, IEEE Catalog No. 99ch36291c.	
	3	Madou, Marc, Fundamentals of Microfabrication, Chapters 2-4, CRC Press LLC, Boca Raton, FL: 1997.	
	4	Kovacs, Gregory T.A., Micromachined Transducers Sourcebook, Table of Contents, pp. 77-119 and Index, WCB McGraw-Hill, U.S.A.: 1998.	
	5	Teegarden, Darrell et al., How to Model and Simulate Microgyroscope Systems, IEEE Spectrum, 66-75, July 1998.	
	6	Emmerich, Harald et al., Magnetic Field Measurements with a Novel Surface Micromachined Magnetic-Field Sensor, IEEE Transactions on Electron Devices, V. 47 (5) 972-977, May 2000.	
	7	McGruer, N.E. et al., Electrostatically Actuated Microswitches; Scaling Properties, Solid-State Sensor and Actuator Workshop, Hilton Head Island, South Carolina, June 8-11, 1998, pp.132-135.	
	8	Miyajima, Hiroshi et al., High-Aspect-Ratio Photolithography for MEMS Applications, J. of Microelectromechanical Sys., V.4(4) 220-229, Dec. 1995.	
	9	Lu, Crist et al., A Monolithic Surface Micromachined Accelerometer with Digital Output, IEEE J. of Solid State Circuits, V. 30 (12) 1367-1373, Dec. 1995.	
	10	Chen, Ming-Jer et al., Weak Inversion Charge Injection In Analog MOS Switches, IEEE J. of Solid-State Circuits, V. 30 (5) 604-606, May 1995.	
	11	Lemkin, Mark A. et al., A Fully Differential Lateral S ² Accelerometer with Drift Cancellation Circuitry, Solid-State Sensor and Actuator Workshop, Hilton Head, South Carolina, June 2-6, 1996, pp. 90-93.	

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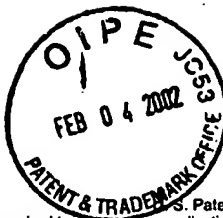
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	12	Boser, Bernhard E., et al., Surface Micromachined Accelerometers, IEEE J. of Solid-State Circuits, V. 31 (3) 366-375, March 1996.	
	13	Fedder, Gary K. et al., Multistage Digital Control of a Suspended Polysilicon Microstructure, J. of Microelectromechanical Sys., V. 5(4) 283-297, Dec. 1996.	
	14	Norlega, Gerardo, Sigma-Delta A/D Converters Audio and Medium Bandwidths, Technical Notes-DT3 from RMS Instruments website: www.rmsinst.com, 6 pages, February 1996.	
	15	Internet page: Decimator Filter DLL, NeuroDimension Inc.: www.nd.com, May 31, 2001.	

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 1 of 1

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Application Number	09/804,817
Filing Date	March 13, 2001
First Named Inventor	Richard D. Harris
Art Unit	2811
Examiner Name	--
Attorney Docket Number	110003.97354 (99AB198)

U. S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US-			
	1	US- 6,428,713	08-06-2002	Christenson, et al.	
	2	US- 5,946,549	08-31-1999	Itoigawa, et al.	
	3	US- 6,008,138	12-28-1999	Laermer, et al.	
	4	US- 6,369,931	04-09-2002	Funk, et al.	
	5	US- 6,159,385	12-12-2000	Yao, et al.	
	6	US- 6,547,973	04-15-2003	Field	
	7	US- 5,723,353	03-03-1998	Muenzel, et al.	
	8	US- 6,276,205	08-21-2001	McNie, et al.	
	9	US- 5,399,232	03-21-1995	Albrecht, et al.	
	10	US- 5,578,528	11-26-1996	Wuu, et al.	
	11	US- 2002/0158039	10-31-2002	Harris, et al.	
	12	US- 2002/0021119	02-21-2002	Yao, et al.	
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Examiner Signature	<i>Kimberly Allen</i>	Date Considered	5/24/04
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